

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.usplo.gov

			•		
APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/730,230	12/08/2003	Bishnu P. Gogoi	SC12116ZP 2513		
23125 759 FREESCALE SE	03/20/2007 MICONDUCTOR, INC	EXAMINER			
LAW DEPARTM	IENT	ESTRADA, MICHELLE			
7700 WEST PARMER LANE MD:TX32/PL02 AUSTIN, TX 78729			ART UNIT	PAPER NUMBER	
,		2823			
SHORTENED STATUTORY F	PERIOD OF RESPONSE	MAIL DATE	DELIVERY MODE		
3 MONT	HS	03/20/2007	PAPER		

Please find below and/or attached an Office communication concerning this application or proceeding.

If NO period for reply is specified above, the maximum statutory period will apply and will expire 6 MONTHS from the mailing date of this communication.

		Applicati	on No.	Applicant(s)				
Office Action Summary		10/730,2	30 ·	GOGOI ET AL.				
		Examine	r	Art Unit				
		Michelle	Estrada	2823				
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply								
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).								
Status		•						
1)[	Responsive to communication(s) file	ed on 23 January 200	)7.	•				
	This action is <b>FINAL</b> . 2b)⊠ This action is non-final.							
, —	Since this application is in condition	•		secution as to the	e merits is			
· / <b></b>	closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.							
Disposition of Claims								
4)⊠	Claim(s) 1-23 is/are pending in the	application.						
•	4a) Of the above claim(s) is/are withdrawn from consideration.							
	Claim(s) 23 is/are allowed.							
·	<ul> <li>✓ Claim(s) 1-9,11,14 and 19-22 is/are rejected.</li> </ul>							
·	Claim(s) <u>10,12,13 and 18</u> is/are obj		· ·					
·	Claim(s) are subject to restri		requirement.					
,	on Papers		•					
	The specification is objected to by the			<b>.</b>				
10)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.								
	Applicant may not request that any obje				, , _ , , , , , , , , , , , , , , ,			
	Replacement drawing sheet(s) including							
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.								
Priority u	nder 35 U.S.C. § 119							
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of:								
	1. Certified copies of the priority							
	<ol><li>Certified copies of the priority</li></ol>	documents have bee	en received in Applicati	on No				
	<ol><li>Copies of the certified copies</li></ol>	of the priority docum	ents have been receive	ed in this National	Stage			
application from the International Bureau (PCT Rule 17.2(a)).								
* See the attached detailed Office action for a list of the certified copies not received.								
•		÷						
Attachment(s)  1) Notice of References Cited (PTO-892)  4) Interview Summary (PTO-413)								
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) Paper No(s)/Mail Date								
3) 🔲 Inform	nation Disclosure Statement(s) (PTO/SB/08)	·- <b>,</b>	5) D Notice of Informal P					
Paper No(s)/Mail Date 6) Other:								

### **DETAILED ACTION**

### Continued Examination Under 37 CFR 1.114

A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 1/23/07 has been entered.

## Claim Rejections - 35 USC § 112

The following is a quotation of the first paragraph of 35 U.S.C. 112:

The specification shall contain a written description of the invention, and of the manner and process of making and using it, in such full, clear, concise, and exact terms as to enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make and use the same and shall set forth the best mode contemplated by the inventor of carrying out his invention.

Claims 1-13 are rejected under 35 U.S.C. 112, first paragraph, as failing to comply with the written description requirement. The claim(s) contains subject matter, which was not described in the specification in such a way as to reasonably convey to one skilled in the relevant art that the inventor(s), at the time the application was filed, had possession of the claimed invention. There is no description in the specification as originally filed of "wherein the insulating layer does not encroach the opening". There is only seen description of actually the insulating layer encroaches the opening as shown in Fig.6, because the insulating is over the limits of the opening and feature 41.

# Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1, 2, 4, 9, 11, 14, 15, 17, 19 and 20 are rejected under 35 U.S.C. 102(b) as being anticipated by Razouk et al. (5,911,109).

Re claims 1 and 2, Razouk et al. disclose providing a semiconductor substrate; forming a layer over the semiconductor substrate (108); forming an opening within the layer (302); forming (depositing) an insulating layer over the layer at approximately atmospheric pressure that would inherently seal the opening (Col. 1, lines 57-65).

Re claims 4 and 17, Razouk et al. disclose wherein forming the insulating layer further comprises depositing the insulating layer and annealing the insulating layer at approximately atmospheric pressure.

Re claim 9, Razouk et al. disclose wherein annealing comprises reflowing the insulating layer.

Re claims 11, 19 and 20, Razouk et al. disclose wherein forming an insulating layer comprises forming a phosphosilicate glass (PSG) (Col. 1, lines 55-57).

Re claim 14, Razouk et al. disclose providing a semiconductor substrate; forming a sacrificial layer over the semiconductor substrate (106); forming a layer over the

sacrificial layer (108); etching the layer to expose a portion of the sacrificial layer; removing the sacrificial layer; forming an opening within the layer (302); forming a material over the opening (802); and sealing the opening with the material, wherein sealing occurs at approximately atmospheric pressure (Col. 1, lines 57-65).

Re claim 15, Razouk et al. disclose wherein forming the material and sealing the opening are performed simultaneously.

## Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 3, 5-8, 16, 21 and 22 rejected under 35 U.S.C. 103(a) as being unpatentable over Razouk et al. as applied to claims 1, 2, 4, 9 and 11 above, and further in view of the following comments.

Re claims 3 and 16, Razouk et al. do not disclose wherein the depositing is performed by CVD.

However, the Examiner takes official notice that depositing an insulating layer by CVD is well known in the art at the time of Applicant's invention. It would have been obvious to one of ordinary skill in the art to deposit the insulating layer by CVD to achieve the instant invention.

Re claims 5-8, 21 and 22, Razouk et al. do not specifically disclose a type of annealing process.

The Examiner takes official notice that furnace anneal, localized anneal, annealing in dopant atmosphere and laser anneal are well known in the art at the time of Applicant's invention. It would have been obvious to one of ordinary skill in the art to use any of these types of anneal to achieve the instant invention. See Sze, "VLSI Technology", pages 355-362.

## Allowable Subject Matter

Claim 23 is allowed.

Claims 10, 12, 13 and 18 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

### Response to Arguments

Applicant's arguments filed 1/23/07 have been fully considered but they are not persuasive. Applicant argues that Razouks encroaches the opening because the glass material fills the opening and argues that the present invention "does not encroach the opening". However, Fig. 6 of the present invention shows the insulating layer being encroached in the opening.

Art Unit: 2823

Conclusion

Page 6

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Michelle Estrada whose telephone number is 571-272-

1858. The examiner can normally be reached on Monday through Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Matthew Smith can be reached on 571-272-1907. The fax phone number

for the organization where this application or proceeding is assigned is 571-273-8300.

Any inquiry of a general nature or relating to the status of this application or

proceeding should be directed to the receptionist whose telephone number is 571-272-

2800.

Information regarding the status of an application may be obtained from the

Patent Application Information Retrieval (PAIR) system. Status information for

published applications may be obtained from either Private PAIR or Public PAIR.

Status information for unpublished applications is available through Private PAIR only.

For more information about the PAIR system, see http://pair-direct.uspto.gov. Should

you have questions on access to the Private PAIR system, contact the Electronic

Business Center (EBC) at 866-217-9197 (toll-free).

ME

March 16, 2007